

U.S. Department of Commerce, Patent and Trademark Office				Atty Docket No.		Serial No.		
				M-12327 US		Not yet known		
INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Applicant(s)				
(Use several sheets if necessary)				Dong, Zhong et al.				
				Filing Date		Group		
				Herewith		Not yet known		
U.S. Patent Documents								
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
MSP	AA	2001/0021588	09/13/01	Misium et al.				
MSP	AB	4,613,956	09/23/86	Paterson et al.	365	185		
MSP	AC	6,074,954	06/13/00	Lill et al.	438	710		
MSP	AD	6,248,628	06/19/01	Hilliyal et al.	438	257		
MSP	AE	6,261,903	07/17/01	Chang et al.	438	257		
MSP	AF	6,268,296	07/31/01	Misium et al.	438	763		
MSP	AG	6,274,902	08/14/01	Kauffman et al.	257	316		
	AH							
	AI							
	AJ							
	AK							
Foreign Patent Documents								
							Translation	
		Document	Date	Country	Class	Subclass	Yes	No
	AL							
	AM							
	AN							
	AO							
	AP							
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)								
MSP	AQ	M. Arai et al., "Remote Plasma Nitridation for Flash Tunnel Oxide", Non-Volatile Semiconductor Memory Workshop 2001, (pp. 125-127).						
	AR							
	AS							
Examiner		Date Considered						
MSP		8/8/02						
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.								

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10/07/02
02/08/02